



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1734
Examiner: Yewebdar T. Tadesse

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu YAMAUCHI)

Serial No.: 10/670,725)

Filing Date: September 26, 2003)

For: PHOTORESIST APPLYING DEVICE)
AND APPLYING METHOD THEREFOR)

Atty. Dkt.: OKI 378)

AMENDMENT

September 15, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on June 1, 2005, the period for response to which is extended by a Petition for a One-month Extension of Time filed herewith, please amend the above-identified application as follows: